



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shinichi SHINOZUKA, et al. **Confirmation No.: 2094**  
U.S. Serial No. : 10/581,073  
Filed: : May 31, 2006  
Examiner : Ronald D. Hartman  
Group Art Unit : 2121  
For : METHOD OF CONTROLLING SUBSTRATE PROCESSING  
APPARATUS AND SUBSTRATE PROCESSING APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on May 30, 2008, to which the time for response is set to expire August 30, 2008, please amend the above-identified application as set forth below and consider the following remarks. In addition, a check in the sum of \$210 accompanies this response for one extra independent claim.

Amendments to the Claims begin on page 2.

Remarks begin on page 7.